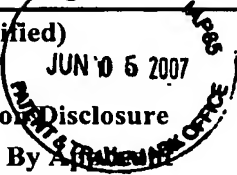


<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	<b>Atty Docket No.</b>	NOVLP068/NVLS-2818
	<b>Application No.:</b>	10/690,084
	<b>Applicant</b>	Koos et al.
	<b>Filing Date</b>	October 20, 2003
	<b>Group</b>	1765
		Page 1 of 1

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Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
/LV/	1.	7,056,648	06.2006	Cooper et al.			
/LV/	2.	4,181,760	01.1980	Feldstein, Nathan			
/LV/	3.	2002/0084529	07.2002	Dubin et al.			

#### Foreign Patent or Published Foreign Patent Application

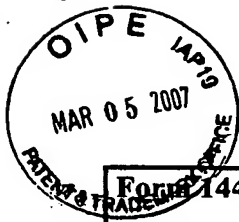
Examiner Initial	Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
						Yes	No
	4.	JP02111883	04.1990	JPO			

#### Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
/LV/	5.	Mayer et al., "Pad-Assisted Electropolishing," Novellus Systems, Inc., Appln No.: 11/213,190, filed August 26, 2005. [NVLS-3037]
/LV/	6.	Mayer et al., "Topography Reduction and Control by Selective Accelerator Removal," Novellus Systems, Inc., Appln. No.: 11/602,128, filed November 20, 2006. [NVLS-2960]
/LV/	7.	Aksu et al., "The Role of Glycine in the Chemical Mechanical Planarization of Copper," Journal of The Electrochemical Society, 149 (6) G352-G361 (200), Department of Materials Science and Engineering, University of California, Berkeley, Berkeley, California 94720-1760, USA
/LV/	8.	U.S. Office Action mailed August 16, 2006 from U.S. Application No. 10/742,006. [NOVLP065/NVLS-2796]

<b>Examiner</b>	/Lan Vinh/	<b>Date Considered</b>	07/30/2007
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Atty Docket No.	Application No.:
	NOVLP068/NVLS-2818	10/690,084
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	Koos et al.	
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#### U.S. Patent and Publication Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
/LV/	A1	6,975,032	12/2005	Chen et al.			

#### Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	B1							

#### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	
Examiner /Lan Vinh/		Date Considered 03/21/2007

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Atty Docket No. NOVLP068/NVLS-2818 Applicant: Koos et al. Filing Date October 20, 2003	Application No.: 10/690,084  Group 1765
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**U.S. Patent and Publication Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
/L V/	A1	6,975,032	12/2005	Chen et al.			

**Foreign Patent or Published Foreign Patent Application**

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	B1							

**Other Documents**

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	
Examiner /Lan Vinh/		Date Considered 03/21/2007

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